

JS401-200 Spin Coater

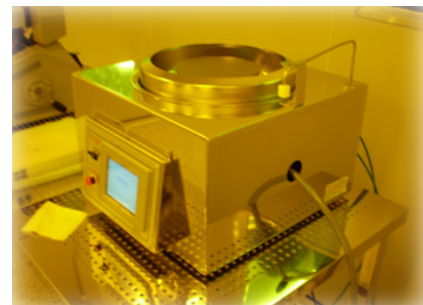
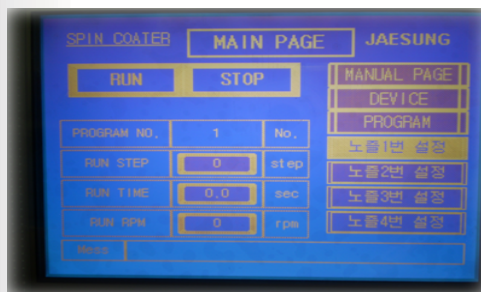
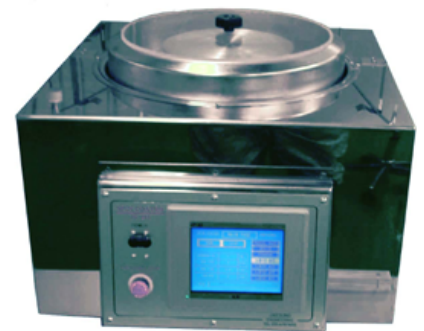
200 mm Spin Coater

The JS401-200 benchtop Series of small substrate spincoaters is designed for versatility, ease of use and safety in a variety of manual and automated research and development processes. The spincoaters are ideal for processes such as the coating and developing of silicon wafers, glasses, large photomasks, reticles.

- Easy to clean up the bowl
- Easy to use
- Repeatable performance
- Flexibility
- Programmability in an economical, benchtop system.

Specification

Programmable 20 steps, 20 recipes stored
PLC and Touch panel operation
Accuracy ± 1 RPM
Max RPM: 4,500
Acceleration and deceleration settable by 0.1 sec.
Acceleration: 3,000RPM/sec.
SUS304 body and bowl
for easy cleaning and chemical resistance
Drain port
Clear PC cover for bowl
Max 200mm diameter plate
Standard dry vacuum pump: 100 liter/ min, 0.5 ATM
Standard sample chuck
Dimension 500W x 500D x 375H mm
220VAC, 60Hz, 5 amp
Weight: 25 Kg



JAESUNG JS401 SPIN COATING SYSTEM

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